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Please find below and/or attached an Office communication concerning this application or proceeding.

		A	1 A 14			
		Application No.	Applicant(s)			
Office Action Summary		10/712,048	TOKUNAGA ET AL.			
		Examiner	Art Unit			
		German Colón	2879			
Period fo	The MAILING DATE of this communication app or Reply	pears on the cover sheet with the c	orrespondence address			
THE I - Exter after - If the - If NO - Failu Any r	ORTENED STATUTORY PERIOD FOR REPL'MAILING DATE OF THIS COMMUNICATION. Insions of time may be available under the provisions of 37 CFR 1.1 SIX (6) MONTHS from the mailing date of this communication. Period for reply specified above is less than thirty (30) days, a reple period for reply is specified above, the maximum statutory period or reply within the set or extended period for reply will, by statute eply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be tin y within the statutory minimum of thirty (30) day will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).			
Status	·		·			
1) 又	Responsive to communication(s) filed on 14 N	lovember 2003.	·			
2a)□	This action is <b>FINAL</b> . 2b) $\boxtimes$ This action is non-final.					
3)□						
Dispositi	on of Claims					
5)□ 6)⊠ 7)□	4) ☐ Claim(s) 1-9 is/are pending in the application.  4a) Of the above claim(s) is/are withdrawn from consideration.  5) ☐ Claim(s) is/are allowed.  6) ☐ Claim(s) 1-9 is/are rejected.  7) ☐ Claim(s) is/are objected to.  8) ☐ Claim(s) are subject to restriction and/or election requirement.					
Applicati	on Papers					
10)⊠	The specification is objected to by the Examine The drawing(s) filed on 14 November 2003 is/a Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct The oath or declaration is objected to by the Example 1.	are: a)⊠ accepted or b)⊡ object drawing(s) be held in abeyance. Sec tion is required if the drawing(s) is ob	e 37 CFR 1.85(a). jected to. See 37 CFR 1.121(d).			
Priority u	ınder 35 U.S.C. § 119					
12) ⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a) ⊠ All b) □ Some * c) □ None of:  1. ⊠ Certified copies of the priority documents have been received.  2. □ Certified copies of the priority documents have been received in Application No  3. □ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).  * See the attached detailed Office action for a list of the certified copies not received.						
2) Notice	t(s) le of References Cited (PTO-892) le of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) r No(s)/Mail Date <u>111403</u> .	4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal F 6) Other:				

## **DETAILED ACTION**

## Response to Preliminary Amendment

1. The Pre-Amendment, filed on November 14, 2003, has been entered and acknowledged by the Examiner.

# Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (a) the invention was known or used by others in this country, or patented or described in a printed publication in this or a foreign country, before the invention thereof by the applicant for a patent.
- 3. Claims 1, 2 and 9 are rejected under 35 U.S.C. 102(a) as being anticipated by Hirose (JP 2002-367531).

Regarding claim 1, Hirose discloses a mask structure for use in a CRT (see Figs. 1 and 2) comprising:

a color-separating mask (see Fig. 2) made of a thin metal plate having a row of slits 9 formed therein with a predetermined pitch, the color-separating mask having a first hole-bearing area including all of the slits of the row except two outermost slits 11A of the row and two second hole-bearing areas each of which includes one of the outermost slits 11A (see Fig. 3); and

a mask frame 12 holding the mask while applying tension perpendicular to a direction in which the slits are arranged to the mask (see Fig. 2);

wherein the thin metal plate has first projections 16 formed therein for each of the outermost slits, the first projections protruding to an opening of corresponding one of the outermost slits, and

wherein an opening area of the outermost slits of the second hole-bearing areas is smaller than an opening area of the slits of the first hole-bearing area (see Figs. 3A-3B and paragraph [0019]).

Regarding claim 2, Hirose discloses the opening area of the outermost slits of the second hole-bearing areas being smaller than 70% of the opening area of the slits of the first hole-bearing area (see paragraph [0019]).

Regarding claim 9, Hirose discloses a CRT including the mask structure (see Figs. 1 and 2).

# Claim Rejections - 35 USC § 103

- 4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 5. Claims 1-3, 6, 7 and 9 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kim et al. (US 6,472,806) in view of Shiohara et al. (US 5,396,145).

Referring to claims 1 and 9, Kim discloses a mask structure for use in a CRT (see Fig. 3) comprising:

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a color-separating mask 40 made of a thin metal plate having a row of slits 42 formed therein with a predetermined pitch, the color-separating mask having a first hole-bearing area including all of the slits of the row except two outermost slits of the row and two second hole-bearing areas each of which includes one of the outermost slits (see Figs. 4-5);

a mask frame 50 holding the mask while applying tension perpendicular to a direction in which the slits are arranged to the mask; and

wherein the thin metal plate has first projections 44,45 formed therein for each of the outermost slits, the first projections protruding to an opening of corresponding one of the outermost slits. Kim is silent regarding the limitation of an opening area of the outermost slits being smaller than an opening area of the slits of the first hole-bearing area.

However, in the same field of endeavor, Shiohara discloses a mask having a row of slits 11, the mask having a first hole-bearing area and two second hole-bearing areas, and teaches to provide an opening area of the outermost slits 12a-12d smaller than an opening area of the slits in the first hole-bearing area with the purpose of maintaining the end slits 11a at the opposite ends of the effective area of the picture secured with a correct width (see Figs. 1(a)-4(a) and Col. 2, lines 27-34). Thus, it would have been obvious to one of ordinary skill in the art at the time the invention was made to provide the outermost slits with an opening area smaller than that of the slits of the first hole-bearing area, in order to maintain the end slits at the opposite ends of the effective area of the picture secured with a correct width, improving the image quality.

Referring to claim 2, Kim-Shiohara discloses the opening area of the outermost slits of the second hole-bearing areas being smaller than 70% of the opening area of the slits of the first hole-bearing area (see `145, Col. 3, lines 7-9).

Referring to claim 3, Kim-Shiohara discloses the thin metal plate having second projections formed therein for each of the slits of the first hole-bearing area, the second projections protruding to an opening of corresponding one of the slits of the first hole-bearing area (see '806, Figs. 3-5).

Referring to claims 6 and 7, Kim-Shiohara discloses the first projections being formed on only one of the opposite sides of the opening of the outermost slits of the second hole-bearing area with a predetermined pitch in a direction of length of the outermost slit, and the second projections being formed on only one of the opposite sides of the opening of the slit of the first hole-bearing area with a predetermined pitch in a direction of length of the slit of the first hole-bearing area (see '806, Figs. 4-5).

6. Claims 1, 3 and 8 are rejected under 35 U.S.C. 103(a) as being unpatentable over Moore (US 4,926,089) in view of Shiohara et al. (US 5,396,145).

In regards to claim 1, Moore discloses a mask structure for use in a CRT (see Figs. 2a, 13 and 14) comprising:

a color-separating mask (see Fig. 2a) made of a thin metal plate having a row of slits 3 formed therein with a predetermined pitch, the color-separating mask having a first hole-bearing area including all of the slits of the row except two outermost slits of the row and two second hole-bearing areas each of which includes one of the outermost slits (see Figs. 11, 12 and 14);

a mask frame (see Figs. 2a and 14; and respective description) holding the mask while applying tension perpendicular to a direction in which the slits are arranged to the mask; and

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wherein the thin metal plate has first projections 82 formed therein for each of the outermost slits, the first projections protruding to an opening of corresponding one of the outermost slits. Moore is silent regarding the limitation of an opening area of the outermost slits being smaller than an opening area of the slits of the first hole-bearing area.

However, in the same field of endeavor, Shiohara discloses a mask having a row of slits 11, the mask having a first hole-bearing area and two second hole-bearing areas, and teaches to provide an opening area of the outermost slits 12a-12d smaller than an opening area of the slits in the first hole-bearing area with the purpose of maintaining the end slits 11a at the opposite ends of the effective area of the picture secured with a correct width (see Figs. 1(a)-4(a) and Col. 2, lines 27-34). Thus, it would have been obvious to one of ordinary skill in the art at the time the invention was made to provide the outermost slits with an opening area smaller than that of the slits of the first hole-bearing area, in order to maintain the end slits at the opposite ends of the effective area of the picture secured with a correct width, improving the image quality.

In regards to claim 3, Moore-Shiohara discloses the thin metal plate having second projections formed therein for each of the slits of the first hole-bearing area, the second projections protruding to an opening of corresponding one of the slits of the first hole-bearing area (see '089, Figs. 12 and 14).

In regards to claim 8, Moore-Shiohara discloses the second projections being formed on opposite sides of the opening of the slit of the first hole-bearing area in a staggered format with a predetermined pitch in a direction of length of the slit of the first hole-bearing area (see '089, Figs. 12 and 14).

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7. Claims 1 and 3-5 are rejected under 35 U.S.C. 103(a) as being unpatentable over Shin et al. (US 6,630,775) in view of Shiohara et al. (US 5,396,145).

Regarding claim 1, Shin discloses a mask structure for use in a CRT (see Figs. 3, 5 and 8) comprising:

a color-separating mask (see Fig. 3) made of a thin metal plate having a row of slits 33 formed therein with a predetermined pitch, the color-separating mask having a first hole-bearing area including all of the slits of the row except two outermost slits of the row and two second hole-bearing areas each of which includes one of the outermost slits (see Figs. 4-8);

a mask frame 40 holding the mask while applying tension perpendicular to a direction in which the slits are arranged to the mask; and

wherein the thin metal plate has first projections 34 formed therein for each of the outermost slits, the first projections protruding to an opening of corresponding one of the outermost slits. Shin is silent regarding the limitation of an opening area of the outermost slits being smaller than an opening area of the slits of the first hole-bearing area.

However, in the same field of endeavor, Shiohara discloses a mask having a row of slits 11, the mask having a first hole-bearing area and two second hole-bearing areas, and teaches to provide an opening area of the outermost slits 12a-12d smaller than an opening area of the slits in the first hole-bearing area with the purpose of maintaining the end slits 11a at the opposite ends of the effective area of the picture secured with a correct width (see Figs. 1(a)-4(a) and Col. 2, lines 27-34). Thus, it would have been obvious to one of ordinary skill in the art at the time the invention was made to provide the outermost slits with an opening area smaller than that of

the slits of the first hole-bearing area, in order to maintain the end slits at the opposite ends of the effective area of the picture secured with a correct width, improving the image quality.

Regarding claim 3, Shin-Shiohara discloses the thin metal plate having second projections formed therein for each of the slits of the first hole-bearing area, the second projections protruding to an opening of corresponding one of the slits of the first hole-bearing area (see `775, Figs. 4-8).

Regarding claims 4 and 5, Shin-Shiohara discloses the first projections being formed in pairs of projections on opposite sides of the opening of the outermost slit of the second hole-bearing area with a predetermined pitch, and the second projections being formed in pairs of projections on opposite sides of the opening of the slit of the first hole-bearing area (see `775, Figs. 4, 5 and 8).

## Prior Art of Record

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure:

JP 2001-167710, JP 2001-155653 and JP 2001-291476 disclose a mask having an outermost slit of opening area smaller than the opening area of the slits in the effective region of the mask.

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Contact Information

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to German Colón whose telephone number is 571-272-2451. The

examiner can normally be reached on Monday thru Thursday, from 8:30 to 6:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Nimesh Patel can be reached on 571-272-2457. The fax phone number for the

organization where this application or proceeding is assigned is 703-872-9306.

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KARABI GUHARAY
PRIMARY EXAMINER

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